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PATENT
Attorney Docket No. 402959

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

KUME et al.

Art Unit: 1752

Application No. 10/765,272

Examiner: Unassigned

Filed: January 28, 2004

For: WET ETCHING APPARATUS AND
WET ETCHING METHOD USING
ULTRAVIOLET LIGHT

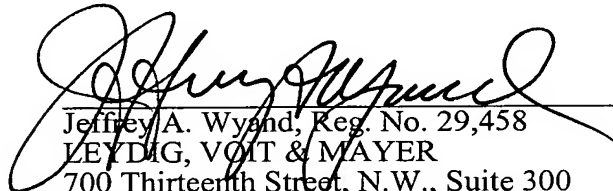
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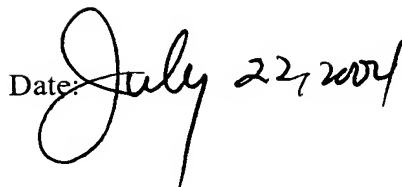
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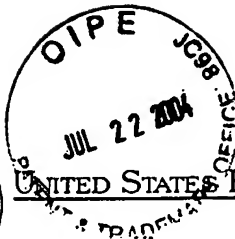
Dear Sir:

An error has been noted on the Official Filing Receipt in the referenced application, namely, the second applicant's address is incorrect. Please issue a Corrected Official Filing Receipt correcting this error as marked in red on the attached copy of the Official Filing Receipt.

Respectfully submitted,


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Date:  July 22, 2004



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10/765,272	01/28/2004	1752	900	402959/TAKADA	2	11	2

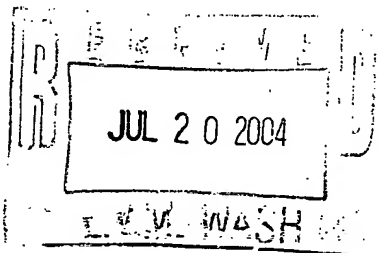
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IBARAKI

Assignment For Published Patent Application

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 Ushio Denki Kabushiki Kaisha, Tokyo-to, JAPAN;

Domestic Priority data as claimed by applicant

Foreign Applications

JAPAN 2003-021566 01/30/2003

If Required, Foreign Filing License Granted: 06/14/2004

Projected Publication Date: 10/28/2004

Non-Publication Request: No

Early Publication Request: No

Title

Wet etching apparatus and wet etching method using ultraviolet light

Preliminary Class

430

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